



Docket No.: 5916/FET/FET/DV

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Young Joseph PAIK

Serial No. 09/998,384

Filed: November 30, 2001

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Group Art Unit: 2812

Examiner:

For: FEEDFORWARD AND FEEDBACK CONTROL FOR CONDITIONING OF
CHEMICAL MECHANICAL POLISHING PAD

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REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned Principal Attorney of record hereby requests that **all correspondence** for the above-identified patent application be directed to the following address:

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Respectfully submitted,

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